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TC 1700 RESPONSE UNDER 37 C.F.R. § 1.116

EXPEDITED PROCEDURE REQUESTED

EXAMINING GROUP 1722

PATENT

Customer No. 22,852

Attorney Docket No. 04329.2230

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Kenji HASHIMOTO) Group Art Unit: 1722
Application No.: 09/503,170) Examiner: R. Davis
Filed: February 14, 2000)
For: RESIN ENCAPSULATING)
APPARATUS AND METHOD)
USED IN A MANUFACTURE OF A)
SEMICONDUCTOR DEVICE)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed October 21, 2003, the period for response to which extends through January 21, 2004, and pursuant to 37 C.F.R. § 1.116, Applicant proposes that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 8 of this paper.

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